

# Patent Assignment Abstract of Title

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**Inventors:** Jung-Yu Hsieh, Chin-Hsiang Lin

**Title:** Method for forming an ONO structure in one chamber

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**Conveyance:** ASSIGNMENT OF ASSIGNORS INTEREST (SEE DOCUMENT FOR DETAILS).

**Assignors:** HSIEH, JUNG-YU
**Exec Dt:** 08/23/2001

LIN, CHIN-HSIANG
**Exec Dt:** 08/23/2001

**Assignee:** MACRONIX INTERNATIONAL CO., LTD.

NO. 16, LI-HSIN RD., SCIENCE-BASED INDUSTRIAL PARK  
HSIN-CHU CITY, TAIWAN R.O.C

**Correspondent:** LOWE HAUPTMAN GILMAN & BERNER

BENJAMIN J. HAUPTMAN  
1700 DIAGONAL ROAD, SUITE 310  
ALEXANDRIA, VA 22314

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